Integrated Device to Simultaneously Characterize Thermal and Thermoelectic Properties

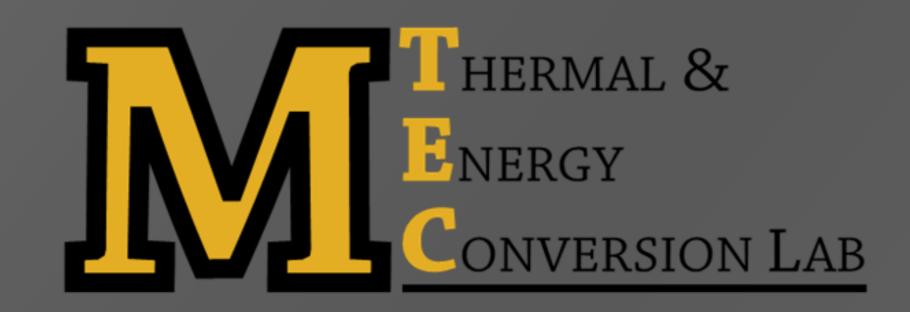
Collier Miers

PI: Amy Marconnet

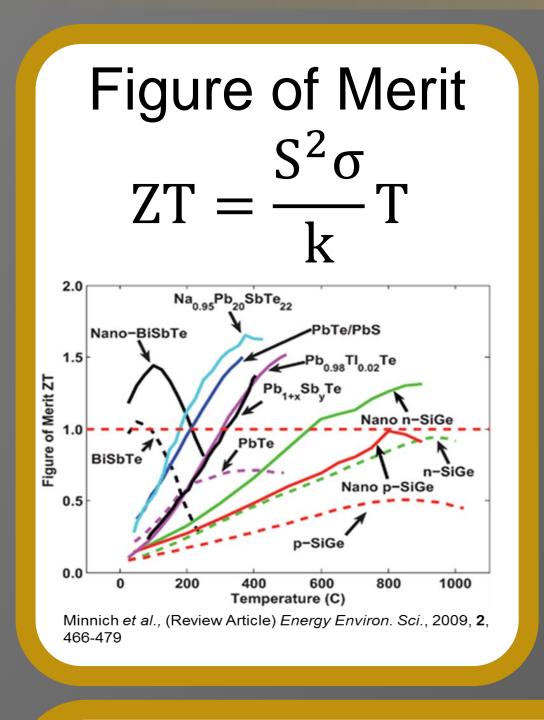
engineering.purdue.edu/MTEC

Key Applications:

- Thermal Management and Electronics Cooling
- Thermoelectric Materials and Applications



Measurement Structure, Optimization, and Fabrication



Heater Spacing

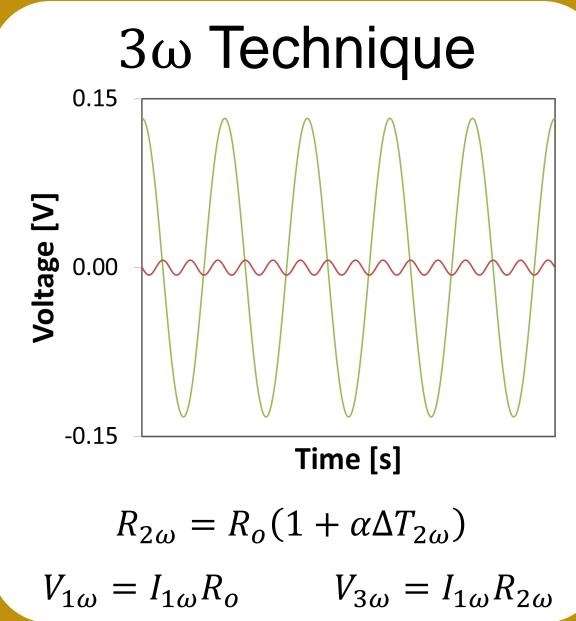
0.4 0.6

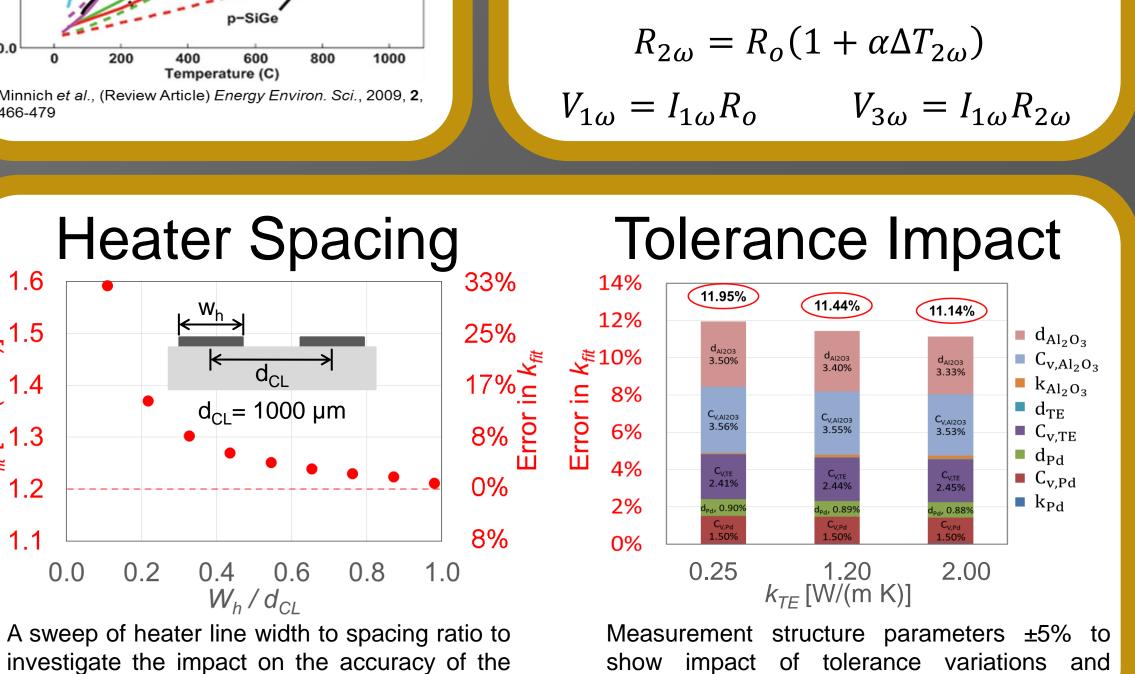
 W_h/d_{Cl}

0.8 1.0

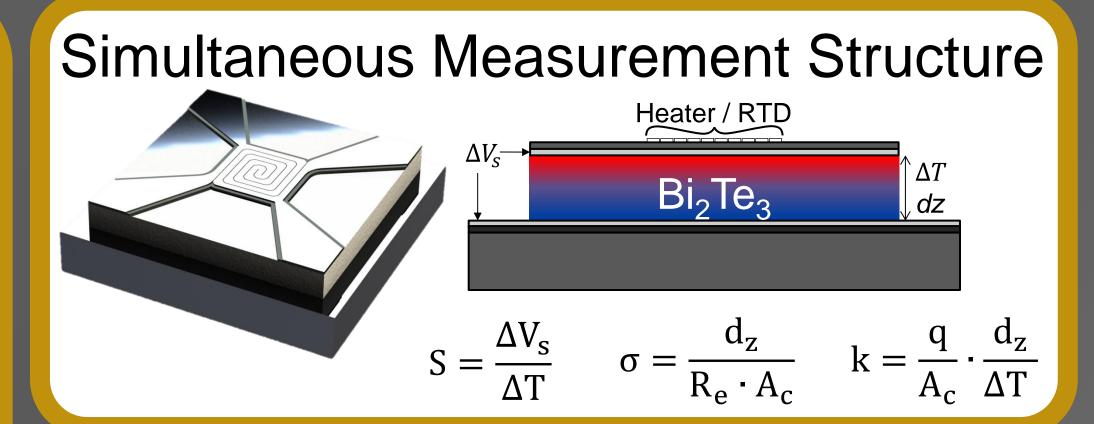
1.5 (Y ⊔)// 1.3 1.2

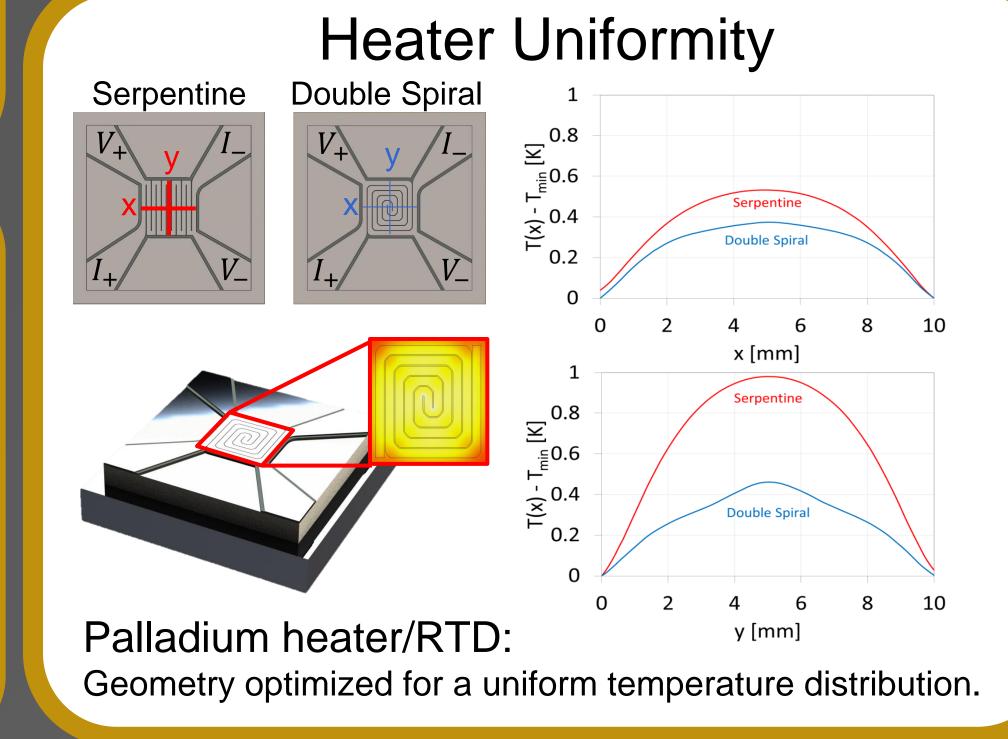
measurement.

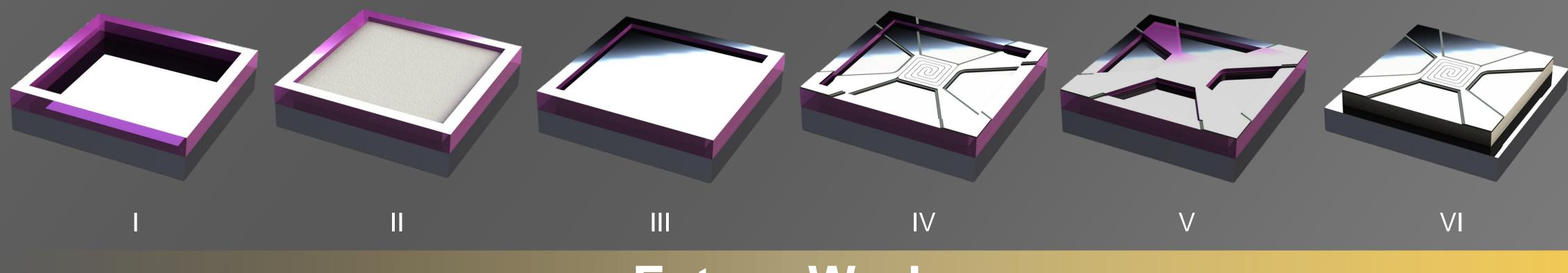




property uncertainty in the fabrication process.







Future Work

Goal: Control and optimization of nanostructure composition and geometry to improve understanding of trends in the thermal properties, allowing optimization for specific applications.

Modeling/Simulation:

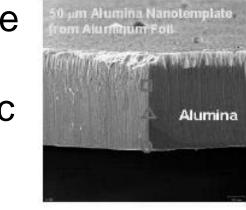
- Enhance current model by incorporating additional physics
 - Thermal losses
 - Electric effects
- New model to investigate the impact of nanostructuring on performance of thermoelectric materials

Experimental:

- Model verification and validation
- System benchmarking with Bi₂Te₃
- Characterization of novel materials
 - Polymers
 - Nanostructured Materials
- High temperature testing
- Device scale testing

Novel Materials:

- Thermally tunable materials through control of nanostructure
 - geometry
- Scalable thermoelectric materials for waste heat recovery



Myung, ECS 2003. Lightweight & thermally conductive metallic structures for heat dissipation

Surfaces for enhanced boiling